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Transport in EuBCO and hybrid graphene/high-temperature
superconductor systems

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摘要



在本篇論文會先對我們腔體最佳條件下的鎔銀銅氧(EuBCO)超導薄膜，做一些電性傳輸的量測分析。為了要確定複合超導體與石墨烯的製程，我們將會針對超導跟一般金屬的複合製程做一些探討跟量測。至今為止，所有複合超體導跟石墨烯的論文中，全部都是以低溫超導作為使用材料，這也就是為什麼我們使用 EuBCO 這樣的第二類高溫超導作為與石墨烯複合的材料的原因。我們藉此希望觀察到流過整個元件的超導電流，以及在超導體與石墨烯的介面發生安德烈夫反射現象的證據。期望因為低溫與高溫超導體在某些物理現象些微的不同，使我們的複合元件能表現出不同的物理現象。

Abstract

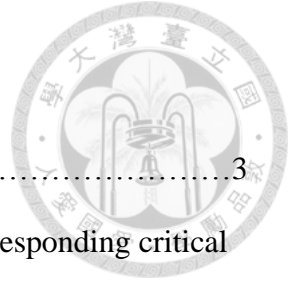


In this thesis, we study the transport properties of the optimum Sputtering condition of the EuBCO superconducting films first. In order to ensure the validity of the superconductor-graphene-superconductor (SGS) structure, we will give some statements about the measuring process of the superconductor-normal metal-superconductor (SNS) structure. Until now, the low-temperature superconductors are used as electrodes for the SGS structure represented in the papers. That is why we combine EuBCO, Type-II high-temperature superconductor, and graphene to make the SGS structure. We may observe the supercurrent passing through the whole device and the phenomena of Andreev reflection between graphene and superconductor. Because of a little different physics between low and high- temperature superconductors, we expect it can represent different physics on our device.

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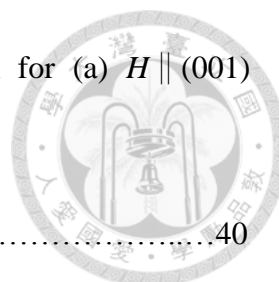


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Chapter 1 Introduction



Superconductivity is a very fascinating physical phenomenon. Until now, there is no complete theorem to describe it. Nevertheless, this field encourages many researchers to spend their energy on the studies, and they hope they can contribute their efforts to exploring the missing pieces of the jigsaw puzzle.

Recently, scientists are interested in metal-oxide again due to the research of high T_c superconductor. Because metal-oxide is highly conductive, it can be made as electrode and microelectronic element. Epitaxial film applied on electromagnetic device has a great potential.

It usually produces innovative and attractive physical phenomena when we integrate some different materials. No matter superconductors combine with normal metal, semiconductor or insulator, the electronic transport will display different ways due to the combination of different materials. In recent years, there are papers representing the combination of the Type-I superconductor and graphene, which lead some results attracting many scientists. In order to comprehend it deeply, we will brief the history of superconductors first in the following section.

1.1 Superconductors

In 1911, Dutch scientist Heike Kamerlingh Onnes used liquid helium for cooling mercury, and then found the resistance of mercury drop suddenly from $10^{-3}\Omega$ to $10^{-6}\Omega$ near 4.2 K [1]. He claimed it transits to a new state below this temperature, which is called “superconducting state”. And this temperature is called “critical temperature”, T_c .

After that, he found that tin and lead also have superconducting properties in 1913; 3.73 K and 7.2 K, respectively. At same time, he found when the material transfer into a superconductor, it will load critical current J_c . And if the current passing through exceed J_c , it will break the properties of superconductor. That is, the material will transfer into normal state.

Just like mercury, alloys can also have superconductivity, too. Therefore, scientists tried to mix different ratio of alloy actively and looked for the possibility of raising T_c . In 1986, Muller and Bednorz found oxide superconductors have very high T_c , such as $\text{La}_{1.85}\text{Ba}_{0.15}\text{CuO}$ ($T_c = 35$ K). They were honored with the Nobel Prize due to this breakthrough. A year later, Taiwan-American scientist Ching-Wu Chu and Maw-Kuen Wu found another oxide superconductor, $\text{YBa}_2\text{Cu}_3\text{O}_{7-\delta}$ (95 K) [2]. This is the first time for T_c of superconductor to exceed the boiling temperature of liquid nitrogen (77 K). Since then, the research of superconductors can be done by using liquid nitrogen as a refrigerant, instead of liquid helium. The copper oxide system discovered in 1986 is called high T_c superconductor. Their T_c can exceed 90 K, which leads scientists have interest in research again. The record of T_c was raised to 125 K by Tl-Ba-Ca-Cu-O copper oxide system at the end of 1987. T_c was raised near 100 K from 1986 to 1987, just more than one year.

In addition to oxide superconductor, MgB_2 was found with T_c achieving 39 K in 2001 [3]. The discovery of this compound rewrites the T_c of non-cuprate superconductor. Then in 2008, the Japan research team found the part oxygen of iron-based oxypnictide can be replaced by doping fluorine, which can let T_c of $\text{LaFeAsO}_{1-x}\text{Fx}$ reach 26 K [4]. Moreover, replacing iron with cobalt [5], replacing rare earth elements with thorium [6], or making the defects of oxygen [7] can also induce superconductivity. The historical evolution of the superconductors is shown in

figure1.1.1.

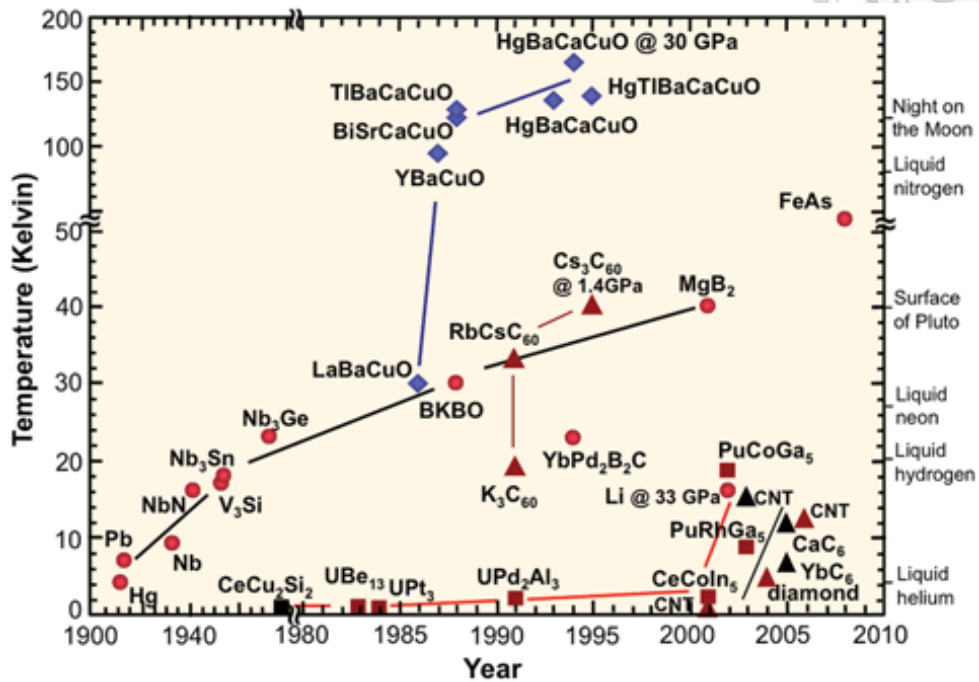
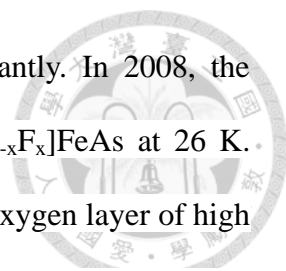


Fig1.1.1: The historical evolution of discovering each superconductor and corresponding critical temperature [8].

So far the theory of superconductor has not been perfect. Nevertheless, the BCS theory which was proposed by American physicists John Bardeen, Leon Neil Cooper, and John Robert Schrieffer in 1957 [9] can be used for explaining the phenomena of superconductor. The BCS theory describes superconductivity as a microscopic effect caused by a condensation of Cooper pairs into a boson-like state. Cooper pairs can transport as current without dissipation. It can explain mechanism of low- T_c superconductor more satisfactorily, but it can't explain successful for high- T_c superconductor or so called "Type-II superconductor".

Before 2008, people widely believed that superconductivity and ferromagnetism could not coexist because of the BCS theory. If we dope some magnetic elements, for



example, Fe and Ni, it can reduce the superconductivity significantly. In 2008, the Professor Hideo Hosono's team found superconductivity of $\text{La}[\text{O}_{1-x}\text{F}_x]\text{FeAs}$ at 26 K. The structure of iron-based superconductor is similar to the copper-oxygen layer of high T_c superconductor, so the superconductivity occurs on the iron-based layer. When iron and other elements form the iron-based layer, iron doesn't have ferromagnetism anymore. Although T_c of iron-based superconductor is just only tens of Kelvins, researching iron-based superconductor can probably help us to realize the mechanism of high T_c superconductor.

1.2 Graphene

Graphene, a single planar sheet of sp^2 -bonded carbon atoms which forms a honeycomb crystal lattice, is only one carbon atom thickness, namely, an actual "2-D" material [10]. The concept of the structure had been discussed for a long time. Once it was believed that graphene can not be stable alone [11]. Nevertheless, scientists still dedicated themselves to seeking a solution for the fabrication process, but the progress was still limited after years of efforts. Until 2004, the Ruso-British physicists Andre Geim and Konstantin Novoselov's research team at the University of Manchester used the "Scotch tape method" [12] to get the graphene from graphite successfully. It proves that graphene can sustain steadily. Therefore, The Nobel Prize in Physics for 2010 was awarded to both of them.

In traditional condense matter physics, the Schrödinger equation is usually used to describe the motion of carriers. On the contrary, the experiments indicate that both the electrons and holes on mono-layer graphene are more similar to massless, relativistic

and spin-1/2 particles due to the ultra-high mobility [13]. Therefore, we need to use Dirac equation to narrate the dynamics of carriers on mono-layer graphene. A “Dirac point” is also called a charge neutrality point. When energy state of graphene is at the Dirac point, that is, around $V_g = 0$, graphene is in the electrically neutral state due to the number of carriers approaching to zero, then the resistance reaches to a maximum. The number of carrier arises with increasing the positive and negative gate bias, namely, it manifests the characteristic of ambipolar of electrical transport shown as figure 1.2.1. Meanwhile, one can also observe “half-integer” Quantum Hall effect from graphene [10]. These fantastic features led to an explosion of interest in this area.

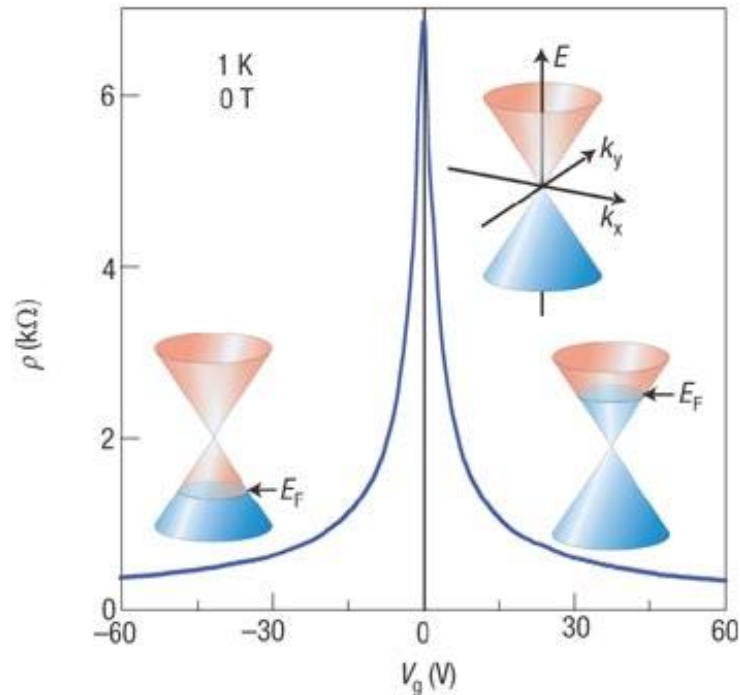
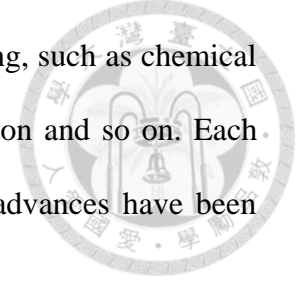


Fig.1.2.1: Ambipolar electric field effect in single-layer graphene [13].

However, the “Scotch tape method” has drawback. That is, the size of graphene sample is very hard to control, so it can’t guarantee the proper size of graphene that we need. On the other hand, the massive production is still strongly limited by the

fabrication progress. Therefore, there are other methods for preparing, such as chemical vapor deposition (CVD) methods on metals [14], chemical reduction and so on. Each preparing has advantages and disadvantages; nevertheless, many advances have been made in the area of fabrication in recent years.



1.3 Motivation and Outline

In previous sections, we have given briefly introduction to the innovation history of superconductivity and graphene. Now we review the physics of the two materials and explore our motivation and outline of this work.

Cooper pairs flow through the superconductors below T_c , and electrons and holes transport through conductors and semiconductors. Since the advent of the graphene, People try to combine superconductor and graphene due to the different transport of graphene. Numbers of literature had witnessed the physics on the interface, and it is different from the combination of normal metal and superconductor. However, all of those reports are about the combinations of low T_c superconductor and graphene, not Type-II high T_c superconductors. This can be expected. We can expect to observe some new physics in our experiment.

First, we had tuned up the best condition of EBCO film. It is better for our process. Then we measured EBCO film for analyzing the electronic properties. To ensure the validity of our process, we made the Josephson junction which is the combination of normal metal and EBCO first. After we ensure the process reached the expected results, we replaced normal metal with graphene.

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Chapter 2 Physics of superconductivity



One of the most obvious features of superconductor is its zero resistance below T_c . And another is the perfect diamagnetism, i.e., the “Meissner effect”. Superconductivity is a critical phenomenon in quantum regime, which cannot be explained by classical physics. Not only the superconductor but also the device “Josephson junction” which is about the tunneling effect of Cooper pair needs to consider the quantum effect, and then they can be explained satisfactorily. We will make a description of the important characteristic and phenomena of superconductor in the following section.

2.1 Meissner effect

When superconductor is at temperature above T_c , magnetic line of flux can pass through its inside freely., just like normal metal or alloy; but when temperature is lower than T_c , the resistivity becomes zero, the magnetic field in a superconductor will be pushed out entirely by induced magnetic field due to the perfect Lenz’s law. Therefore, there is no magnetic field survival within the whole material. Experimentally speaking, the magnetic fields penetrating into the superconductor surface are only about $10^{-5}\sim 10^{-6}\text{cm}$ due to the boundary effect, which means that the superconductor has perfect diamagnetism, and this phenomenon is called “Meissner effect” [1]. From electromagnetism, a magnetized, normal material can be described by the formula.

$$\mathbf{B} = \mu_0(\mathbf{M} + \mathbf{H}), \quad (2.1)$$

where \mathbf{M} is magnetization, and μ_0 is the permeability of free space. Then we define the magnetic susceptibility χ

$$\chi = \frac{M}{H} \quad (2.2)$$

The superconductor in the Meissner-state will represent perfect diamagnetism. That means the susceptibility $\chi = -1$.

$$\mathbf{M} = -\mathbf{H} \quad (2.3)$$

When the superconductor is in the magnetic field, it will produce equal and opposite magnetization to resist the applied magnetic field. When the superconductor is in the magnetic field, it will generate induced current just like normal metal. Because normal metal has resistance, the induced current dissipates soon. The resistance of superconductor is zero, so the induced current can flow and not dissipate. Then it can generate opposite magnetic field to cancel out the applied magnetic field.

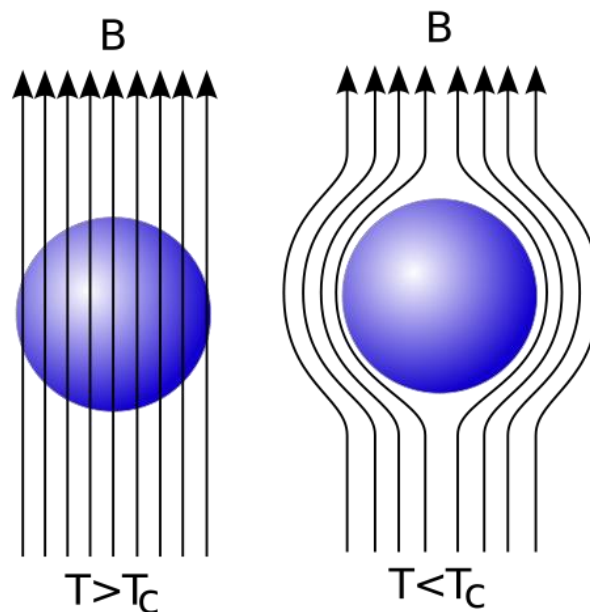


Figure2.1.1: Meissner effect: when the material is in the superconducting state, the magnetic will be pushed out of its internal, which shows the perfect diamagnetism [2].

2.2 Type-II superconductors



There are many ways to classify the superconductivity of a material. The criterions to be addressed in this section are as follows. .

Classified by physical property: Type-I superconductors and Type-II superconductors. (The former belongs to first-order phase transition, and the latter belongs to second-order phase transition.)

Classified by the theory of superconductivity: Traditional superconductors and non-Traditional superconductors. (The former can be explained by BCS theory, but the latter can't.)

Classified by T_c : High T_c superconductors and low T_c superconductors. (The former can use liquid nitrogen to reach superconducting state, but the latter can't.)

Since the upper classifications superconductors can be zero resistance when they reach their T_c , but they have a little different physics in certain conditions.

For Type-I superconductors, when material is in superconducting state, the magnetic field will be excluded. Then we apply a magnetic field overcome a critical strength, the superconductivity will be destroyed. In contrast, for Type-II superconductors, their critical magnetic field has lower and upper values, H_{C1} and H_{C2} . When the applied magnetic fields surpass H_{C1} , parts of magnetic field are allowed to pass through the superconductor. At this time, the superconductor is in the mixed state. The superconductivity vanishes after the applied magnetic fields surpass H_{C2} . The simple representation of the relationship of the superconductor and the applied magnetic field is shown in figure2.2.1

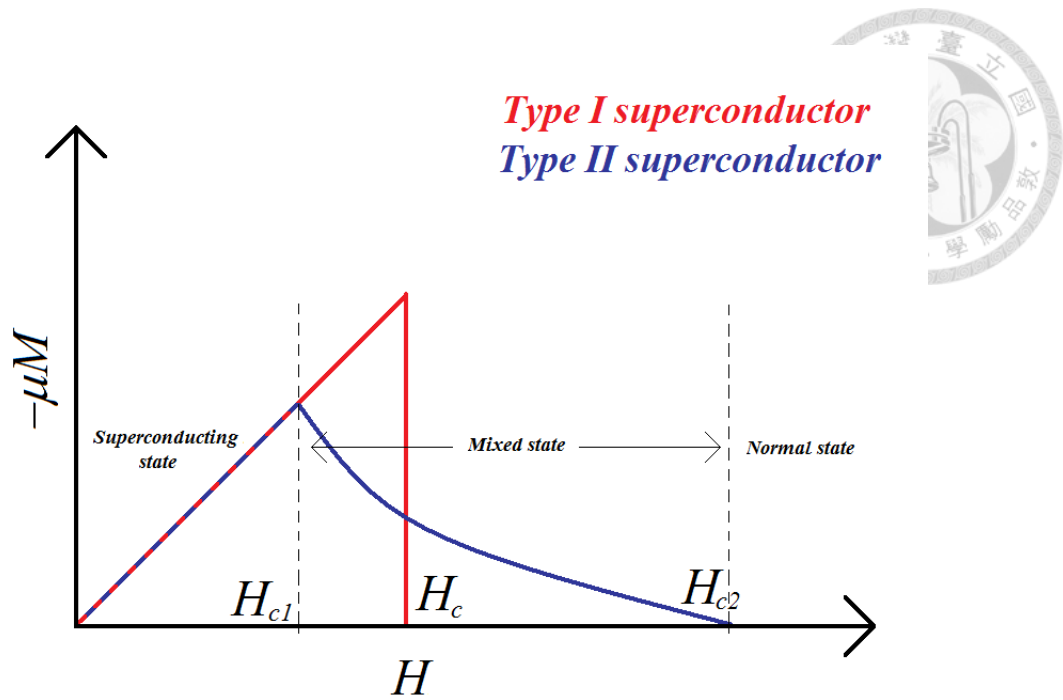


Figure 2.2.1: Magnetization M and applied field H for Type-I and Type-II superconductors [3].

Before the applied magnetic fields reach H_{C1} , the Type-II superconductor is in the Meissner state just like Type-I superconductor. When the applied magnetic fields surpass H_{C1} , which is between H_{C1} and H_{C2} , the parts of applied magnetic fields will enter its interior. Although the Meissner effect is not complete, the Type-II superconductors still have no resistance. In the condition of applied magnetic field and applied current, the magnetic flux in the superconductor will be moved by Lorenz force. This flux motion or “flux-creep” leads the electric energy dissipated. The resistance which is made by flux motion is called “flow resistance”. Meanwhile, the characteristic of zero resistance will vanish gradually.



2.3 Pinning potential energy

Flux pinning is the phenomenon where a superconductor is pinned in space above a magnet. The superconductor must be a Type-II superconductor due to the fact that Type-I superconductors cannot be penetrated by magnetic fields. For Type-II superconductors, when the applied magnetic field H is bigger than H_{C1} and smaller than H_{C2} , the magnetic field lines will enter the superconductor as flux tubes. If the current density J flows, then the motion of magnetic flux will be affected by the Lorentz force $F_L = J \times B$ and the pinning force made by superconducting film $F_P = J_c \times B$.

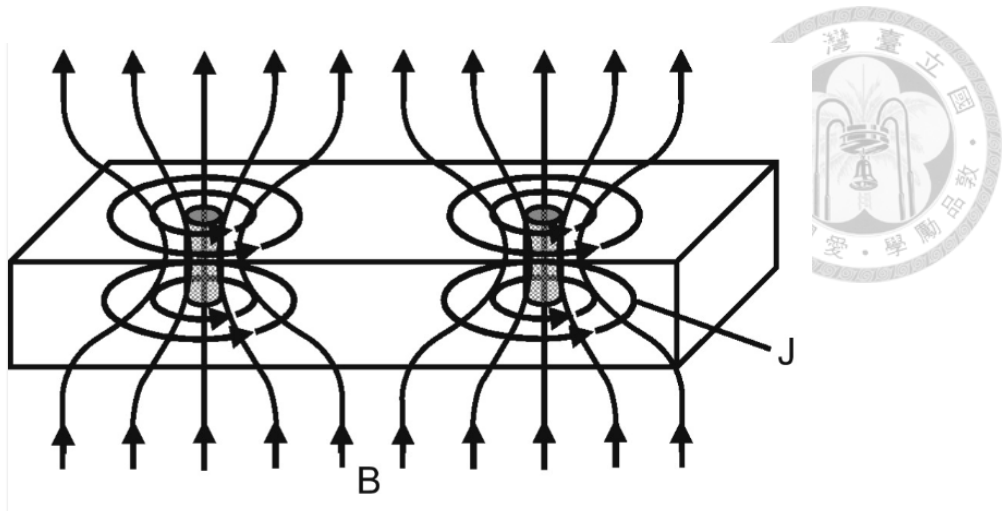
Pinning force is a force acting on a pinned object from a pinning center. The pinning of the magnetic vortices is made by different kinds of the defects in a Type II superconductor. When $T = 0K$, magnetic flux move only if $F_L > F_P$; When $T \neq 0K$, magnetic flux might move due to thermal effect even if $F_L < F_P$. This is Anderson and Kim's flux-creep model [4, 5]. Anderson and Kim considered that the magnetic flux is pinned just like confined by a potential energy well U . U is called pinning potential energy.

According to Anderson and Kim's flux-creep model:

$$\rho_{xx} = \rho_n e^{-U/k_B T} \quad (2.3.1)$$

where U is pinning potential energy, it is related to the direction of applied magnetic field. k_B is Boltzmann constant.

If we make a plot of the natural log of ρ_{xx} and the inverse of temperature, then the slope of this picture is U/k_B . The magnetic flux pinned is shown in figure 2.3.1.



.Figure2.3.1: Magnetic flux lines penetrating a Type-II superconductor when

$$Hc_1 < H < Hc_2 [6].$$

2.4 Josephson junction

Josephson junction consists of two superconductors through a weak link. The middle of two superconductors can be an insulator (S-I-S), normal metal (S-N-S) or superconducting material which can weaken the connection point (S-s-S). It is named after British physicist Brian Josephson. Josephson demonstrated that the mathematical relationship between the current and voltage through a weak link in 1962 [7]. Before Josephson's argument, people think it's just normal (i.e. non-superconducting) electrons through the insulating wall by quantum tunneling. Josephson is the first one who interpreted that this phenomenon is a superconducting Cooper pair tunneling effect. In fact, the Josephson effect has been experimentally observed before 1962. At that time, people commonly considered that electrons were capable of passing through junction due to the very short connecting portion or the destruction of the insulating wall. Now it is a well known effect of superconductivity both in experimental works and theories.



2.4.1 Josephson effect

When there exists a weak coupling between the two pieces of superconductor, the phases of wave functions among both sides should be continuous. Namely, the Cooper pair can be transferred from the superconductor S_1 to the superconductor S_2 through the tunnel; it can also transfer from S_2 to S_1 , and the transmission probability is very small, so it can only be a weak coupling between two superconductors.

In order to get the basic relation of Josephson junction, we consider the wave function of S_1 and S_2 are Ψ_1, Ψ_2 connecting the electric potential difference V , and we assume there is no applied magnetic field [8]. If two superconductors are isolated from each other, then there is no weak coupling. So S_1, S_2 satisfy

$$i\hbar \frac{\partial \psi_j}{\partial t} = H_j \psi_j, \quad j=1,2 \quad (2.4.1)$$

If the weak coupling between two superconductors, it means there is a small transmission of Cooper pairs between the two superconducting. According to Quantum mechanism and Schrödinger equation:

$$i\hbar \frac{\partial \psi_1}{\partial t} = H_1 \psi_1 + K \psi_2 \quad (2.4.2)$$

$$i\hbar \frac{\partial \psi_2}{\partial t} = H_2 \psi_2 + K \psi_1 \quad (2.4.3)$$

where K is coupling constant, it indicates level of coupling between S_1 and S_2 . It depends on the magnitude of the transition probability. If $K \rightarrow 0$, it means that the two superconductors are completely irrelevant, i.e. there is no tunneling phenomenon of Cooper pair.

Because of connecting electric potential difference $V = V_1 - V_2$, the energy difference of Cooper pairs between S_1 and S_2 is

$$H_1 - H_2 = 2eV \quad (2.4.4)$$

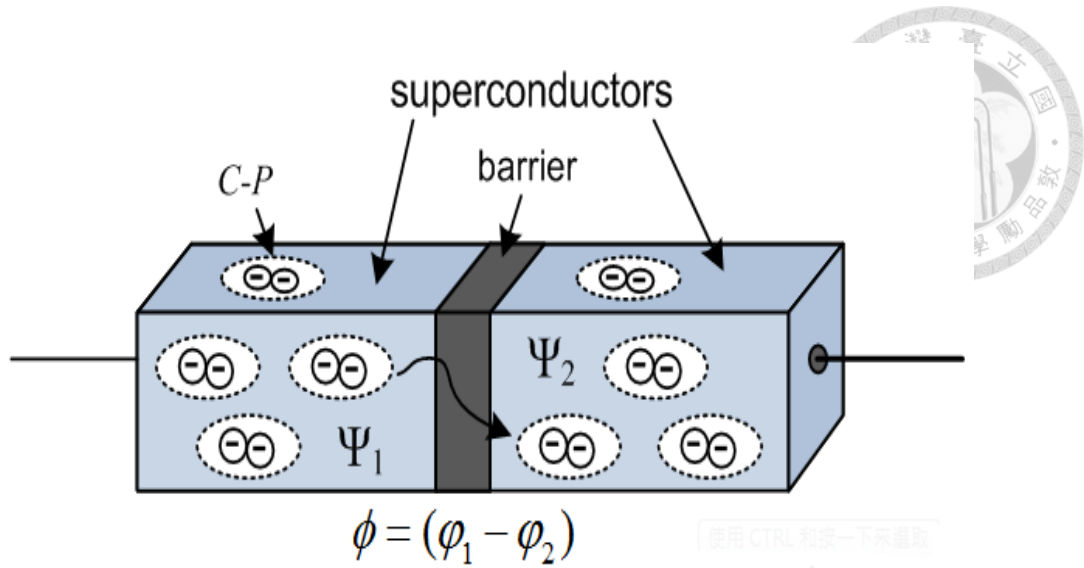


Figure 2.4.1: Josephson junction composed of two superconducting electrodes and weak link [9].

So

$$i\hbar \frac{\partial \psi_1}{\partial t} = eV\psi_1 + K\psi_2 \quad (2.4.5)$$

$$i\hbar \frac{\partial \psi_2}{\partial t} = -eV\psi_2 + K\psi_1 \quad (2.4.6)$$

then we get the form of wave function

$$\psi_1 = \sqrt{\rho_{s1}} e^{i\theta_1} \quad (2.4.7)$$

$$\psi_2 = \sqrt{\rho_{s2}} e^{i\theta_2} \quad (2.4.8)$$

where ρ_{s1} and ρ_{s2} are the density of superconducting electrons, and the phase difference is $\varphi = \theta_1 - \theta_2$.

Eqs. (2.4.7) and (2.4.8) are substituted into eqs. (2.4.5) and (2.4.6), and make both sides of the real part and imaginary part equal to each other. Then get:

$$\frac{\partial \rho_{s1}}{\partial t} = \frac{2}{\hbar} K \sqrt{\rho_{s1} \rho_{s2}} \sin \varphi \quad (2.4.9)$$

$$\frac{\partial \rho_{s2}}{\partial t} = -\frac{2}{\hbar} K \sqrt{\rho_{s1} \rho_{s2}} \sin \varphi \quad (2.4.10)$$

$$\theta_1 = \frac{K}{\hbar} \sqrt{\frac{\rho_{s2}}{\rho_{s1}}} \cos \varphi - \frac{eV}{\hbar} \quad (2.4.11)$$

$$\theta_2 = \frac{K}{\hbar} \sqrt{\frac{\rho_{s1}}{\rho_{s2}}} \cos \varphi + \frac{eV}{\hbar} \quad (2.4.12)$$



If superconductors S_1 and S_2 are the same material, then

$$\rho_{s1} = \rho_{s2} = \rho_0$$

We get

$$j_s = 2e \frac{\partial \rho_{s1}}{\partial t} = \frac{2K}{\hbar} 2e\rho_0 \sin \varphi = j_c \sin \varphi \quad (2.4.13)$$

where j_s is the density of particle flux. $j_c = \frac{4Ke\rho_0}{\hbar}$ is critical current density.

By (2.4.11) and (2.4.12), we can get

$$\frac{d\varphi}{dt} = \frac{2eV}{\hbar} \quad (2.4.14)$$

(2.4.13) is Josephine Current-phase relationship, and (2.4.14) is Josephine voltage - phase relationship. The above two equations can be used to describe the phenomenon of the Cooper pair through the Josephson junction.

2.5 RCSJ model and RSJ model

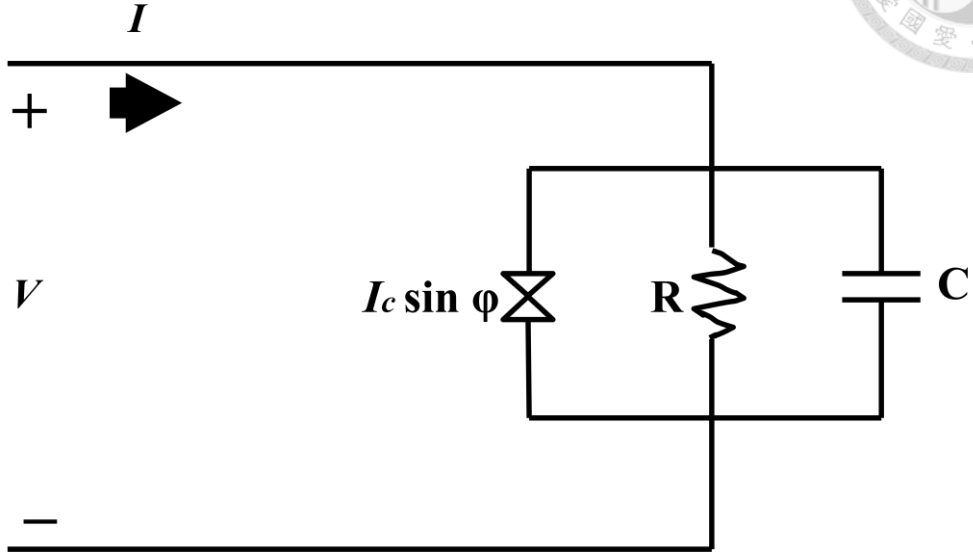


Figure 2.5.1: Resistively Capacitance Shunted Junction [10].

Here we use an equivalent circuit analogy to analyze the physical behavior of Josephson junction effectively, the descriptions are as follows.

Obviously, when the voltage across the junction $V \neq 0$, The current flowing through the weak link is composed of I_s (Josephson current), I_n (Normal current) and I_d (Displacement current) [11]. That is,

$$I = I_s + I_n + I_d \quad (2.5.1)$$

and

$$I_d = C \frac{dV(t)}{dt} \quad (2.5.2)$$

$$I_n = \frac{1}{R} V(t) \quad (2.5.3)$$

where C represents the capacitance between two superconducting electrodes. R is the resistance of junction. So

$$I = I_c \sin \varphi + \frac{1}{R} V(t) + C \frac{dV(t)}{dt} \quad (2.5.4)$$

Consider (2.4.14), then eq. (2.5.4) becomes

$$I = I_c \sin \varphi + \frac{\hbar}{2eR} \frac{d\varphi}{dt} + \frac{\hbar C}{2e} \frac{d^2\varphi}{dt^2} \quad (2.5.6)$$

For superconducting micro-bridge, the electric capacitor can be ignored because of its small value. This model is called Resistively Shunted Junction (RSJ) model.

So eq. (2.5.4) becomes

$$I = I_c \sin \varphi + \frac{\hbar}{2eR} \frac{d\varphi}{dt} \quad (2.5.7)$$

then

$$\frac{d\varphi}{dt} = \frac{2eRI_c}{\hbar} \left(\frac{I}{I_c} - \sin \varphi \right)$$

after calculation

$$V = R(I^2 - I_c^2)^{1/2} \quad (2.5.8)$$

when $I \gg I_c$, $V \sim IR$ is the behavior of Ohm's law. It is shown in figure 2.5.2

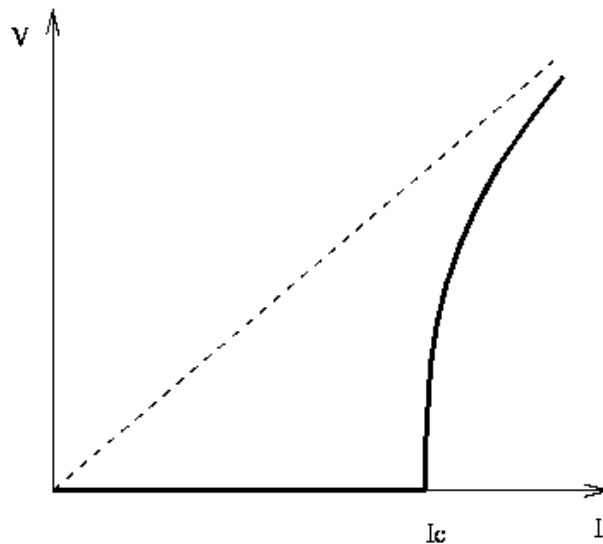


Figure 2.5.2: The current-voltage (I - V) curve of RSJ model [12].

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Chapter 3 Experimental technique and Sample fabrication



3.1 Four-terminal resistance measurement

The most common method for measuring resistance is connecting two probes of a multimeter and measured the object. Then we can read the value of resistance from the multimeter. This is one of most commonly methods to measure the resistance and determine a circuit short or broken. This method, called two-point probe measurement, is the most convenient but difficult to infer a precise value of resistance of devices due to contact resistance.

Contact resistance is one of the most important factors that manipulate the performance of devices. The current heating will affect the contact resistance largely if we want to get the accurate value of resistance. In order to decrease the effect of contact resistance, the four-terminal probe configuration is a better way to minimize the error from contact resistance.

Figure 3.1.1 shows the typical setup of the four-terminal resistance measurement with a Hall bar pattern. The reason for connecting a large resistor is that we can input constant current if the resistance of the sample is relatively smaller than the resistor we set. For example, if we want to input a near constant current $1\mu\text{A}$, then we can connect $1\text{ M}\Omega$ resistor for example and the applied voltage is 1V when the resistance of the sample can be neglected. The longitudinal resistance R_{xx} and Hall resistance R_{xy} are

defined as

$$R_{xx} = \frac{V_{xx}}{I_{SD}} \quad (3.1.1)$$

$$R_{xy} = \frac{V_{xy}}{I_{SD}} \quad (3.1.2)$$

where V_1 and V_2 are the potential difference parallel and perpendicular to the direction of source-drain current I_{SD} , respectively.

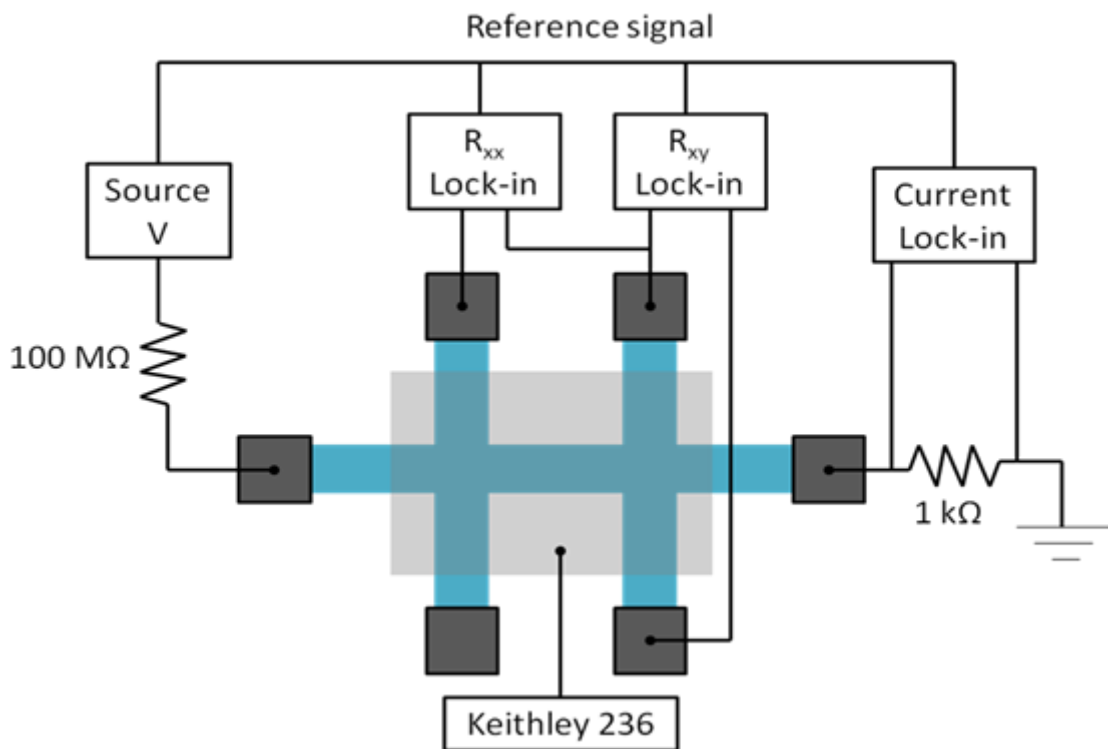


Figure 3.1.1: The schematic diagram of four-terminal resistance measure.

3.2 Sputter system and the process of EuBCO film

Sputter system

- The vacuum system

We use mechanical pump to exhaust air and particles in the chamber. At room

temperature, the sputter system can be exhausted to $2\sim 3 \times 10^{-2}$ torr. The film we coated is oxide, so the degree of vacuum conforms with the requirement of the experiment.



- The heating system

We use three 1000-watts halogen lamps for heating, and use the power supply which can control the program of temperature. We read the temperature by the thermocouple thermometer equipped near the pedestal.

- The RF sputtering gun

Each side of the system has one RF sputtering gun. One is horizontal, and the other is 45 degree as shown in Figure 3.2.1. They are equipped with a EuBCO target. When the RF generation dissociates the Ar atom and produce plasma, the Ar^+ affected by the electrical field and magnetic field will hit the EuBCO target. The EuBCO particles hit by plasma will deposit on the substrate and form a film gradually. In addition, each of the sputtering guns is equipped with shutter.

- The cooling system and protection mechanism

When we coat the film, the system temperature is very high. To protect the magnet of the RF sputtering gun, we input cool water; if we don't, then the power supply can't be turned on.

The details are shown in figure3.2.1.

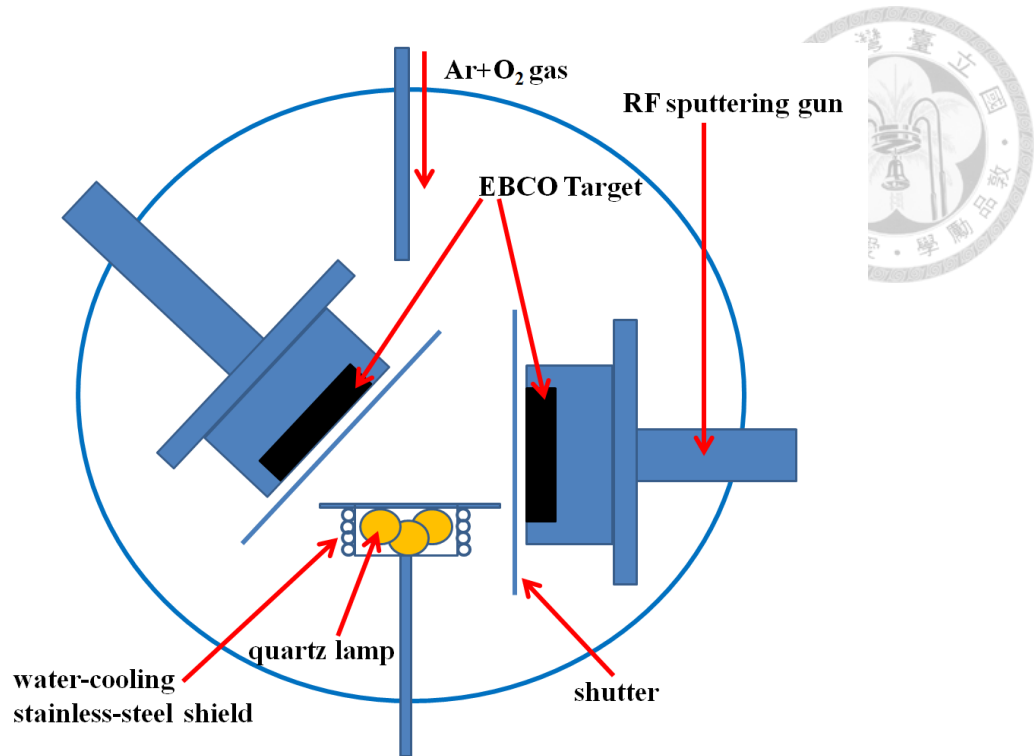
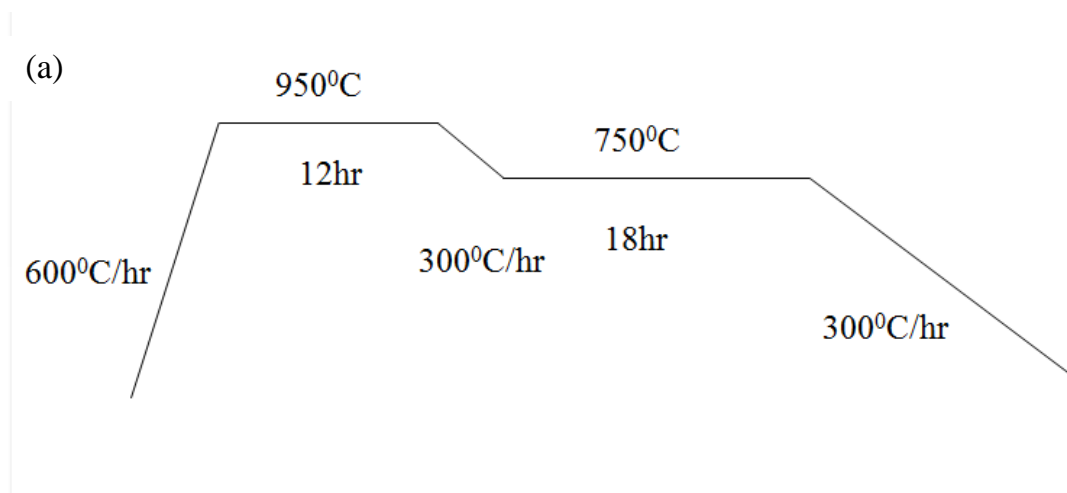


Figure3.2.1: The schematic diagram of the RF sputtering system

The fabrication of EuBCO target

We mixed the EuBCO powders proportionally and made it as 2-inch target. Then we put it into the programmable controller furnace and sinter it. We input pure oxygen during the process of sintering. The EuBCO powders should be sintered twice but different conditions. The detail is show in figure3.2.2.



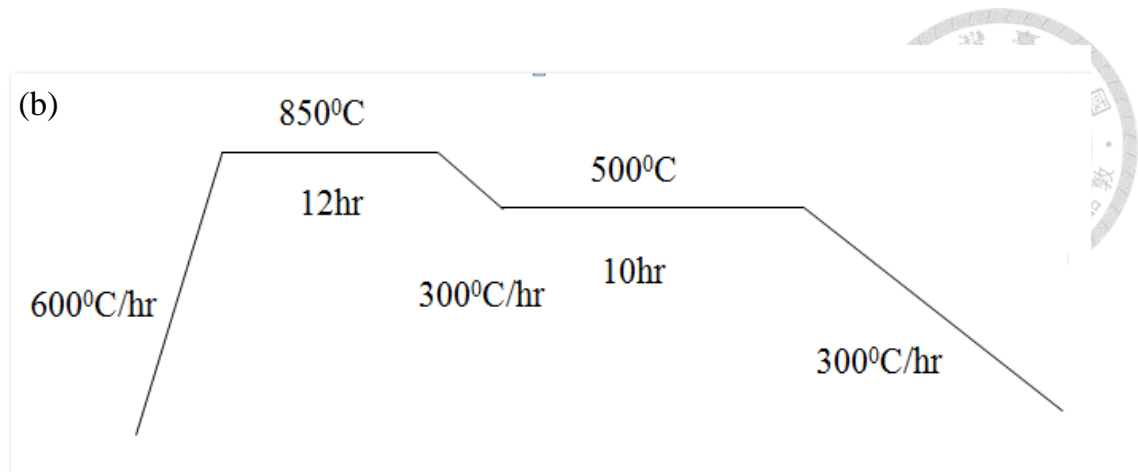


Figure3.2.2: (a) The first process of sintering. (b) The second process of sintering.

Processing of EBCO film

The substrates used for the experiment were (001) single crystal STO (SrTiO_3). First, we used mechanical pump to exhaust air and particles of the chamber to $2\sim 3 \times 10^{-2}$ torr. The temperature of system was raised by a heating rate of 30 degrees per minute. Then we input the mixed gas of $\text{Ar} : \text{O}_2 = 9 : 1$ until reaching the output power of the temperature controller. The pressure of mixed gas was maintained to 350 mtorr by valve and mechanical pump.

We used RF generation to dissociate Ar atoms until the temperature reached stable. Ar atoms will become plasma, and the Ar^+ affected by electric field and magnetic field hit the EuBCO target. The EuBCO particles hit by plasma deposited on the substrate and formed a film gradually.

In order to plant the oxygen in our film sufficiently and make lattice arrangement subtle, we carried out the step of annealing. In this step, we exposed the film under 1atm oxygen for an hour. Then we cooled down the system to 250 degree by 5 degrees per minute. In the final, we cooled down system to room temperature by 15 degrees per minute. The detail of plating EuBCO film is shown in figure.3.2.3.

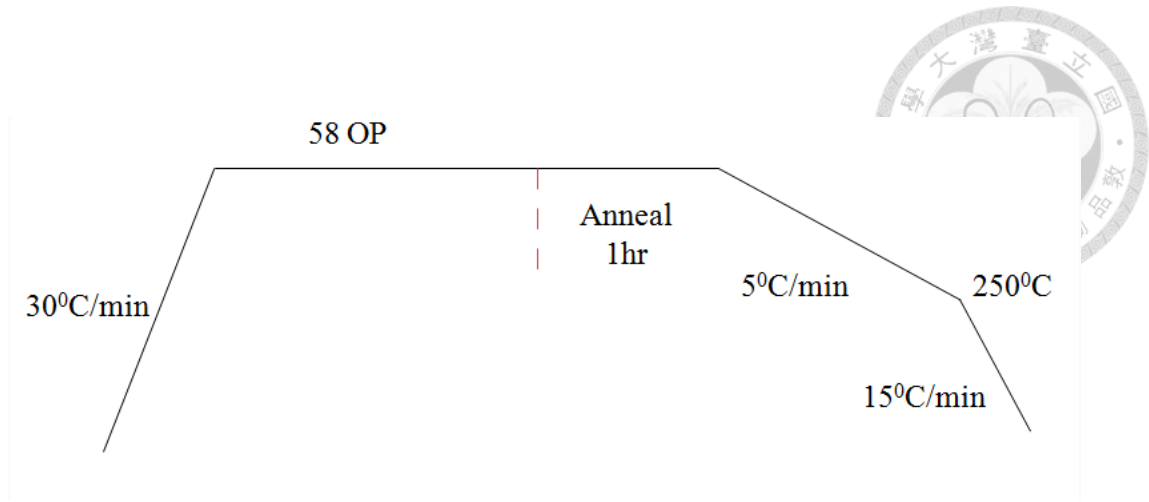


Figure.3.2.3: The process of plating EuBCO film.

3.3 Sample fabrication

For our case, the fabrication of SNS and superconductor-graphene-superconductor structure (SGS) are almost similar. In order to ensure our process, we fabricated SNS first and complied with the similar protocol to fabricate the SGS device. First, we shaped a pattern for EuBCO film as electrodes. The pattern of our mask is shown in figure3.3.1. The width of the micro-bridge is $10\mu\text{m}$, and the length is $200\mu\text{m}$.

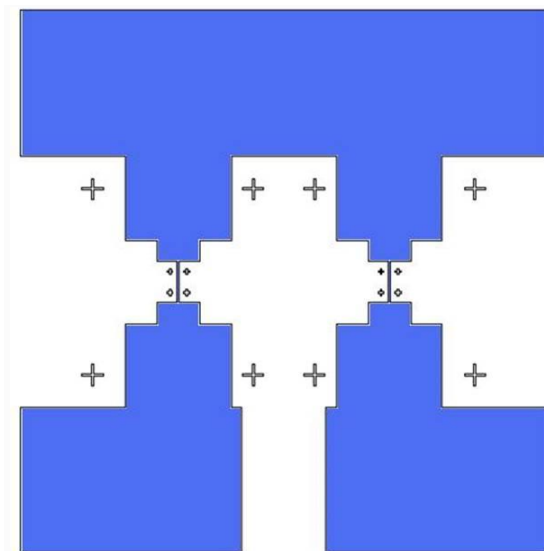


Figure3.3.1: The pattern of mask.

The pattern of electrodes is defined using lithography and acid etch by 0.1% HNO_3 . The process of lithography may affect EuBCO film due to the heating of soft bake for photoresist. Because the Cooper pairs transfer in the copper-oxygen layers, a little high temperature will let oxygen expelled. Since that, we try the better condition of lithography process. Figure 3.3.2 shows that the effect of different temperature of soft bake for EuBCO film.

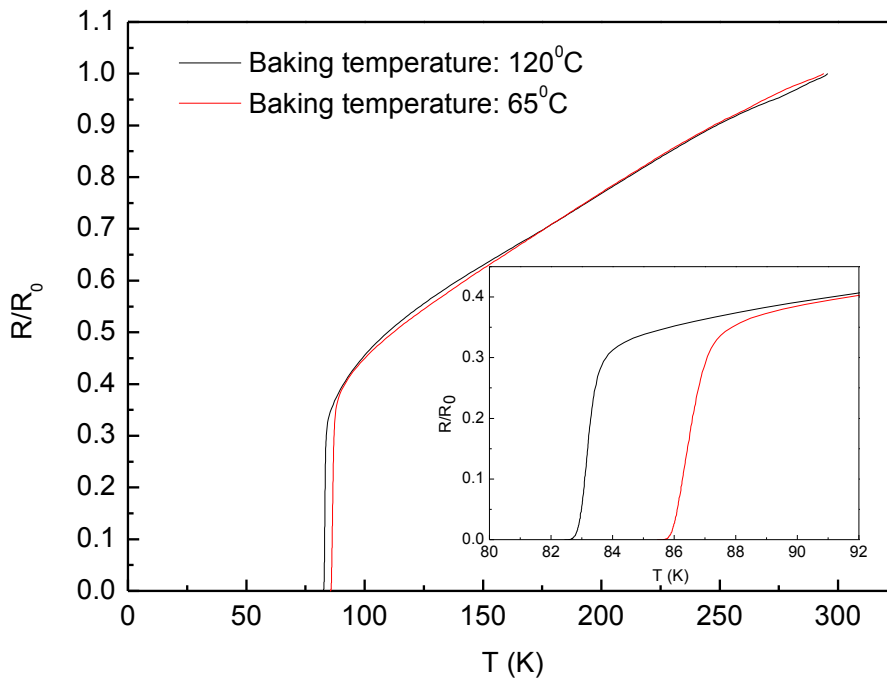


Figure 3.3.2: The effect of different temperature of soft bake for EuBCO film.

After the acid etching, the Focused Ion Beam (FIB) [1] which allows the definition of the traces as narrow as 500 \AA is used to cut the EuBCO micro-bridge. That is because proximity effects are efficient only if the separation between the two superconductive electrodes is small [2]. The gap between two superconducting electrodes is about 100nm. It is shown in figure 3.3.3.

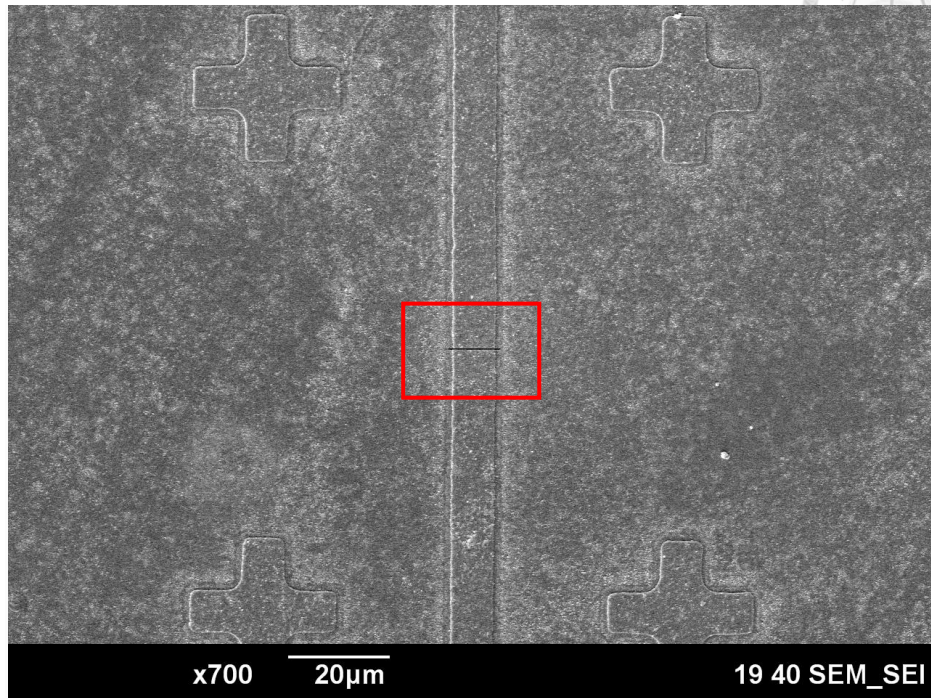


Figure 3.3.3: Scanning electron micrograph of EuBCO micro-bridge cut with a FIB technique.

We coat the gold by high vacuum evaporator system (HVES) on the part of cutting. The SNS was represented by B. Ghyselen et al. in 1992 [3]. They observed that the step of anneal can reduce the contact resistance between the gold and superconducting electrodes. And the supercurrent occurred when the contact resistance is small. Because good electrical contacts with high- T_c superconductors are not so easy to obtain [4, 5], we had to anneal it for reducing the contact resistance. Again, we checked that two electrodes those are disconnected before we coat the gold on it.

After we measure the SNS, we can compare our result with Ghyselen's paper and be sure that the process of SNS is stable although the technique is not perfect. Then the next step is to fabricate SGS. The main difference is the condition of annealing interface. The schematic diagram of SGS structure is shown in figure 3.3.4.

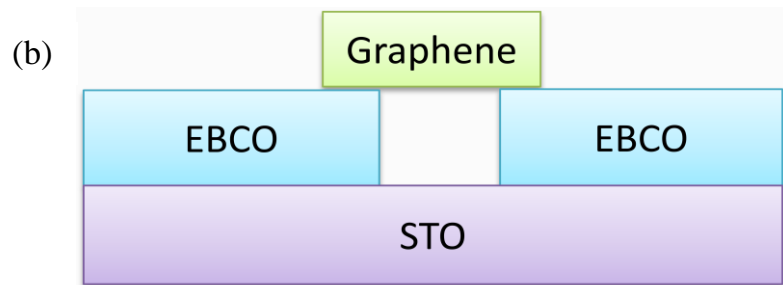
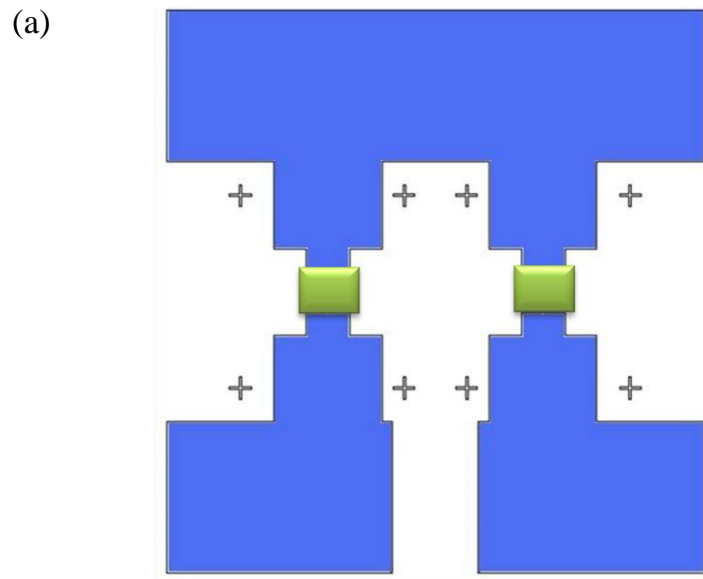


Figure3.3.4: (a) Top-view and (b) side-view of SGS structure for our sample.

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Chapter 4 Results and discussions



In this chapter, we present the test of the characteristic of the superconducting film and the SNS structure before the fabrication of the SGS structure. In order to ensure the validity of our process, the step is necessary before the fabrication of the SGS structure. The following sections are exhibited on the characterizations of the superconducting film, the SNS structure and the SGS structure.

4.1 Measurement of superconducting films

The $\text{EuBa}_2\text{Cu}_3\text{O}_{7-\delta}$ films (EuBCO) were fabricated by sputter. In this section, we measured the electric and magnetic properties by using X-ray diffraction (XRD), FC & ZFC measurement, and resistance-to-temperature measurement with four-terminal resistance measurement.

The crystal structure of EuBCO is shown in figure 4.1.1. The $\text{CuO}_2\text{-Ba-CuO}_2\text{-Ba-CuO}_2$ sandwich is important because the superconductivity occurs on the cooper-oxygen layer. And the pattern used for measuring the characteristic of superconducting film is shown in figure 4.1.2.

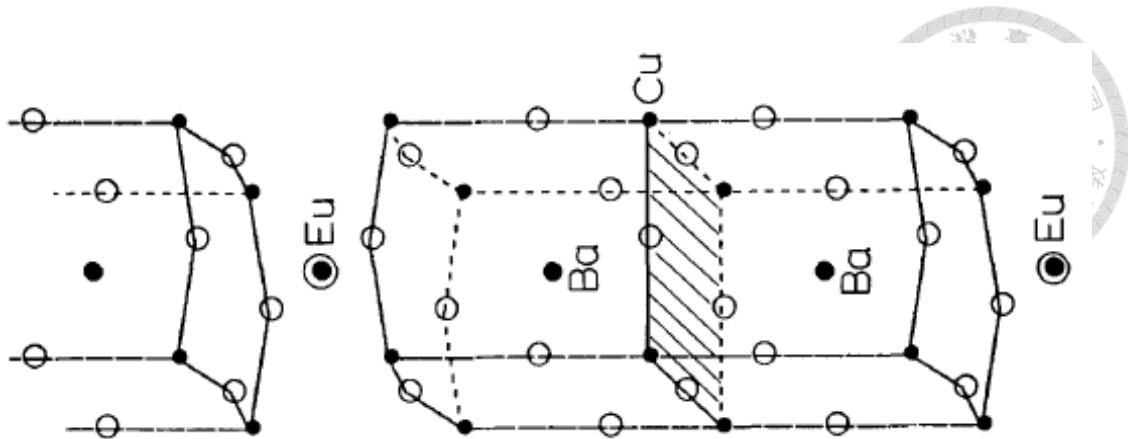


Figure 4.1.1: The crystal structure of EuBCO. The layers of Cu (black) and O (white) normal to the c-axis, here along the horizontal [1].

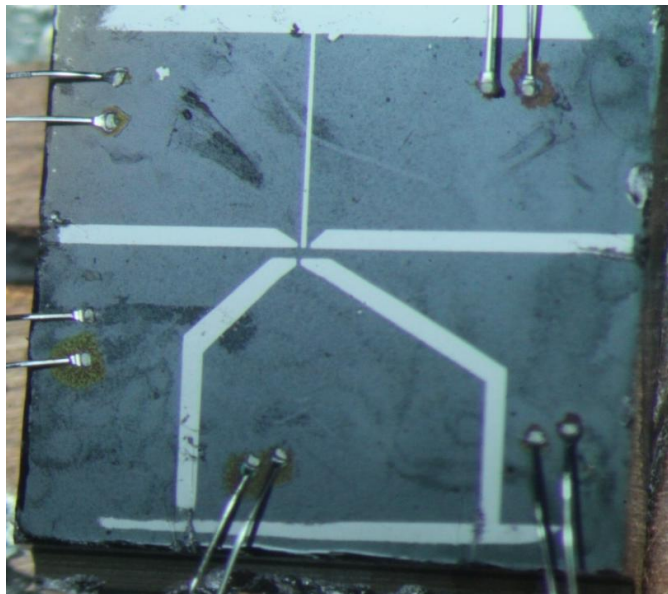


Figure 4.1.2: The pattern for measuring the characteristic of EuBCO films.

Because we mixed the EuBCO powders proportionally and made them as 2-inch targets, the ratio of $\text{Eu}:\text{Ba}:\text{Cu} = 1:2:3$ was expected, that meant our sample compound was in the form of $\text{EuBa}_2\text{Cu}_3\text{O}_{7-\delta}$. In order to make sure the ratio of the EuBCO film, we used an energy dispersive x-ray spectrometer (EDX) to do the check. The result is shown in figure 4.1.3.

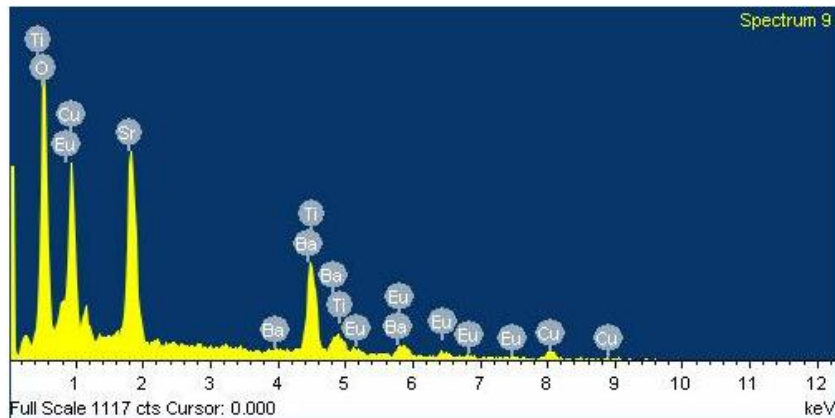
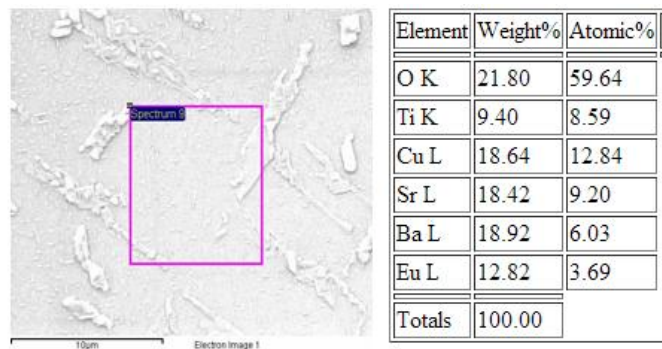


Figure 4.1.3: EDX spectrum and ratio of the EuBCO film.

We can see that the ratio of Eu and Ba is close to the expectation value, but the proportion of Cu is excess about 3%. The EuBCO films were grown on the SrTiO_3 , so we can see that a part of elements are Sr and Ti.

The result from X-ray diffraction analysis for the EuBCO film is shown in figure 4.1.4. The distinguishable peaks indicate that our films are monocrystalline.

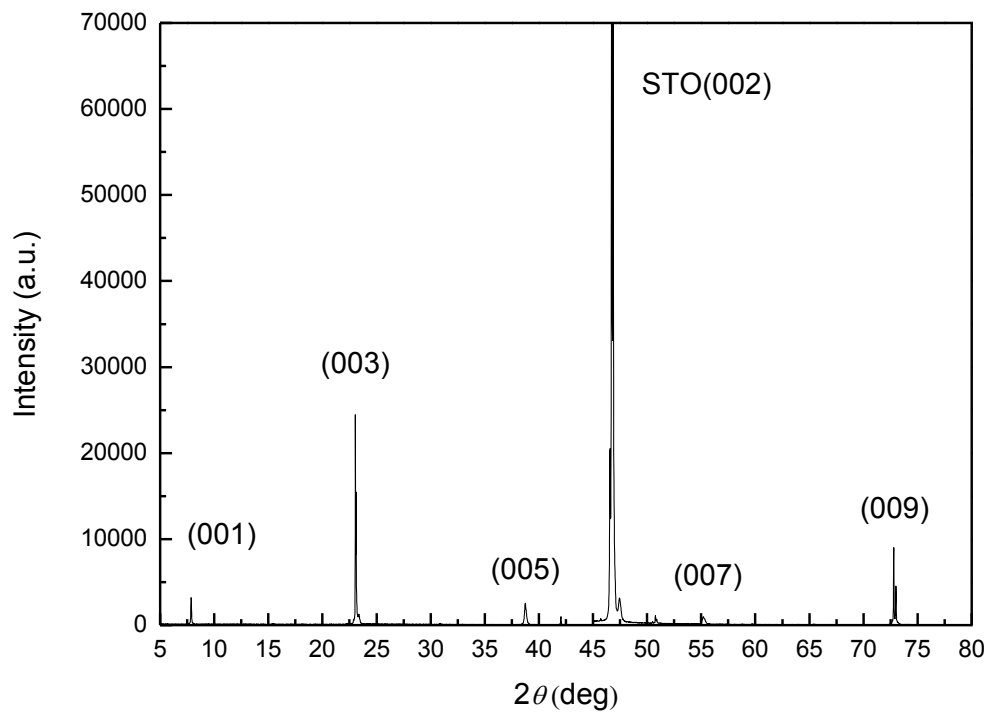


Figure 4.1.4: The XRD diagram of the EuBCO film.

The best T_c of the EuBCO film we'd fabricated is shown in figure 4.1.5, which is close to the result represented by P. H. Hor et al. in 1987 [2]. The $R-T$ curve shows the zero resistance of the EuBCO film when the temperature is below T_c . The optimum sputtering conditions of the EuBCO film is $P = 350 \text{ mTorr}$ ($\text{Ar} : \text{O}_2 = 9 : 1$) and 580P (output power) which is about $T = 700^\circ\text{C}$. The resultant superconducting transition temperature for the optimum deposition condition is about 90K.

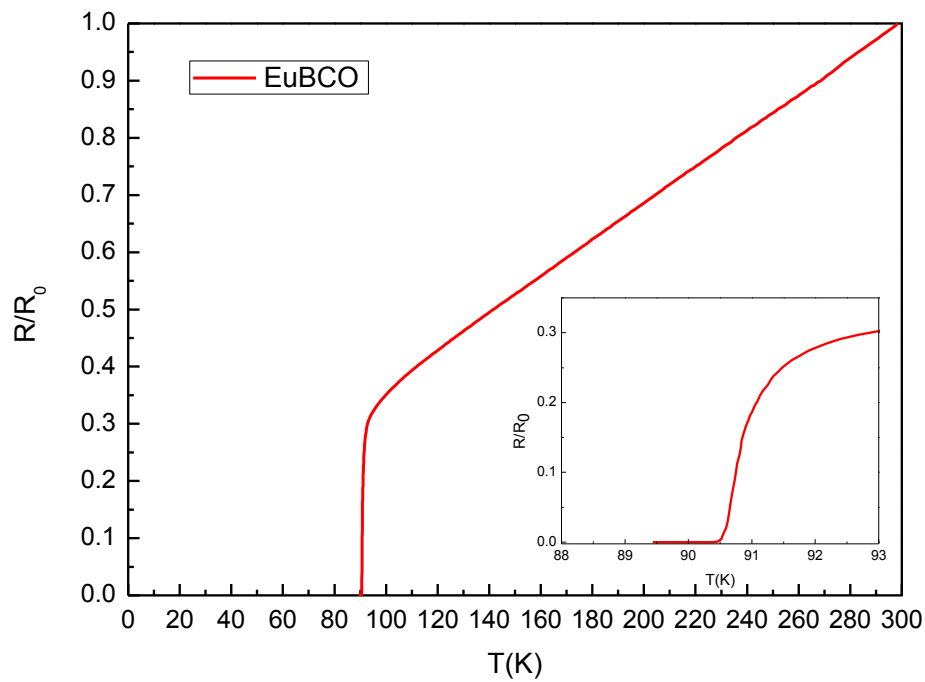


Figure 4.1.5: The $R-T$ diagram of the EuBCO film.

The magnetization-temperature ($M-T$) curves show the characteristics of zero-field cooling (ZFC) and field cooling (FC) for the EuBCO film. We can see the transition temperature of the EuBCO film is about 90K. The magnetization-temperature ($M-T$) curves shown in figure 4.1.6 indicate that our EuBCO film has the characteristics of type II superconductor.

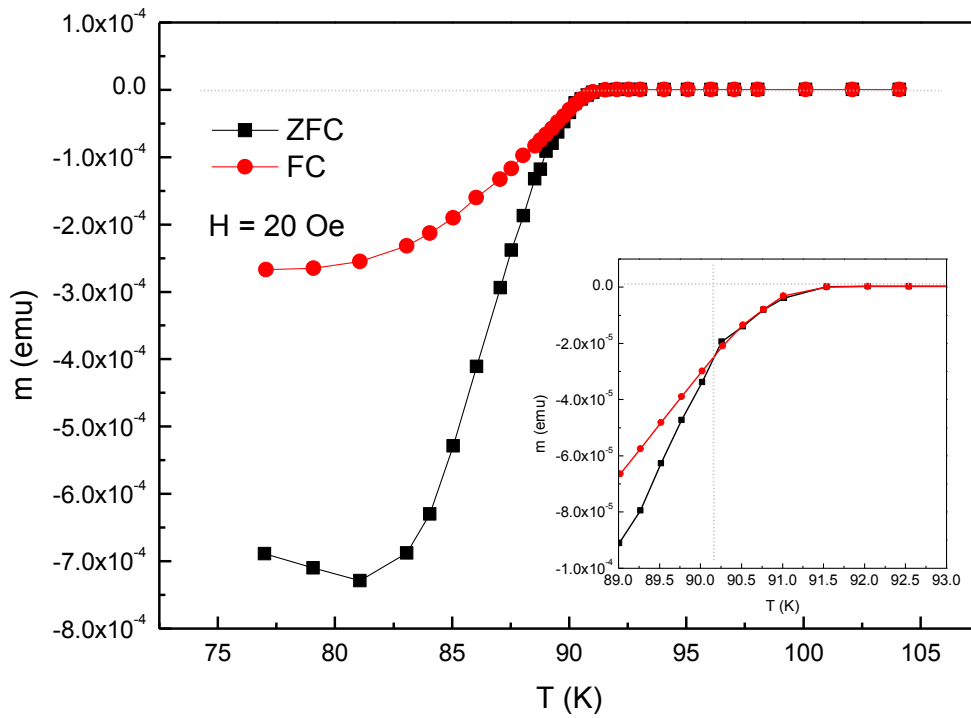
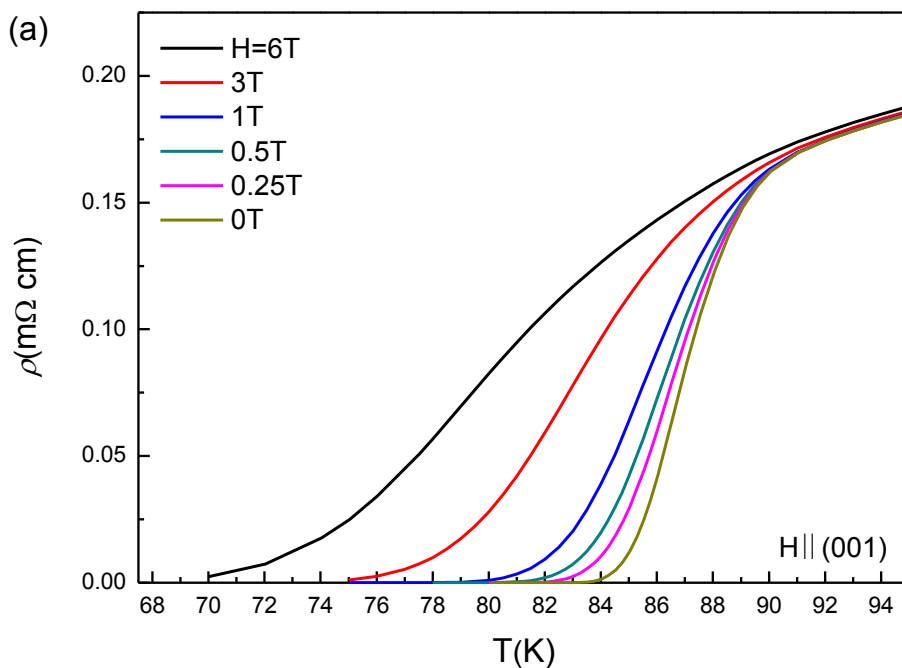


Figure 4.1.6: The $M-T$ diagram of the EuBCO film.



The following are the temperature dependence of $\rho(T)$ in various magnetic fields for $H \parallel (001)$ and $H \perp (001)$. $H \parallel (001)$ means the fields are parallel to the c-axis, and $H \perp (001)$ means the fields are perpendicular to the c-axis. We can see the larger the applied magnetic field, the smaller the corresponding T_c , the tendencies are alike both in $H \parallel (001)$ or $H \perp (001)$.

In figure 4.1.6(a) and (b), we show the resistivities as a function of temperature for EuBCO in magnetic fields of 0, 0.25, 0.5, 1, 3 and 6 *Tesla* parallel and perpendicular to crystal c-axis, respectively. The resistive transition becomes broader in the fields parallel to the c-axis compared with the data obtained with the fields perpendicular to the c-axis. The result indicates the anisotropic properties of the EuBCO film



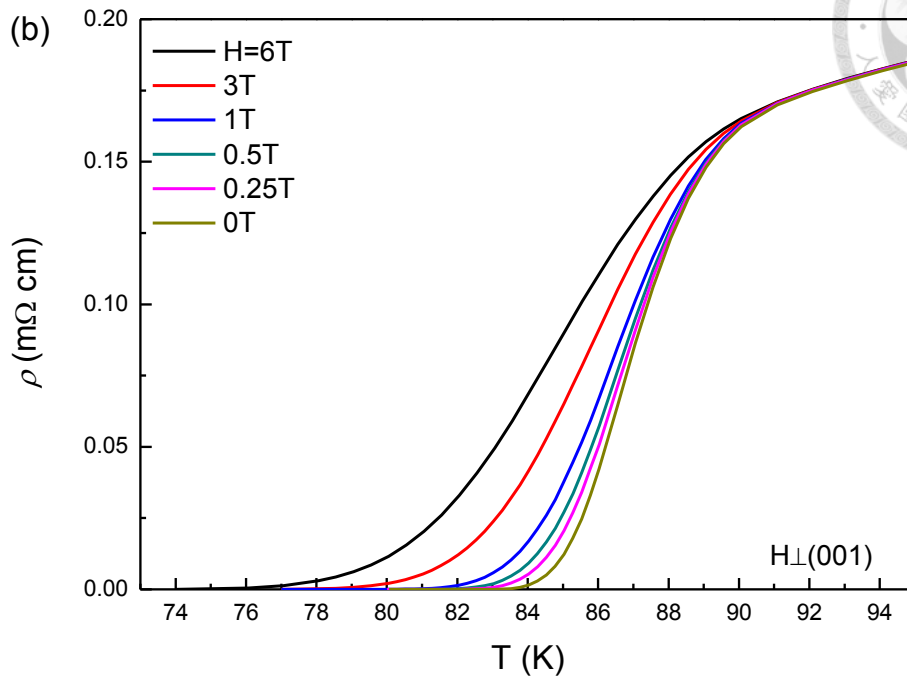
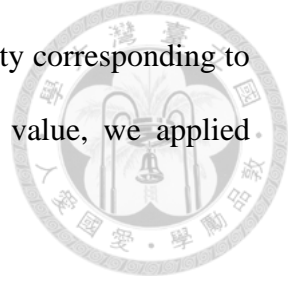


Figure 4.1.7: Temperature dependence of the resistivity $\rho(T)$ of EuBCO film for
 (a) $H \parallel (001)$ (b) $H \perp (001)$ in the magnetic field up to 6 Tesla.



The upper critical fields H_{c2} are defined by ten percent of resistivity corresponding to the $T_{c,onset}$ from figure 4.1.6(a) (b). In order to determine $H_{c2}(0)$ value, we applied Ginzburg – Landau (GL) theory [3]. The GL equation is

$$H_{c2}(T) = H_{c2}(0) * (1 - t^2)/(1 + t^2)$$

where $t = T/T_c$ is the reduced temperature [4].

Therefore, $H_{c2}(0) \parallel (001) = 41.185 \text{ Tesla}$ and $H_{c2}(0) \perp (001) = 122.16 \text{ Tesla}$.

The anisotropy of the upper critical field:

$$\gamma = H_{c2}(0) \perp 001/H_{c2}(0) \parallel (001) = 2.966$$

The slopes are different from both field directions shown in figure 4.1.7.

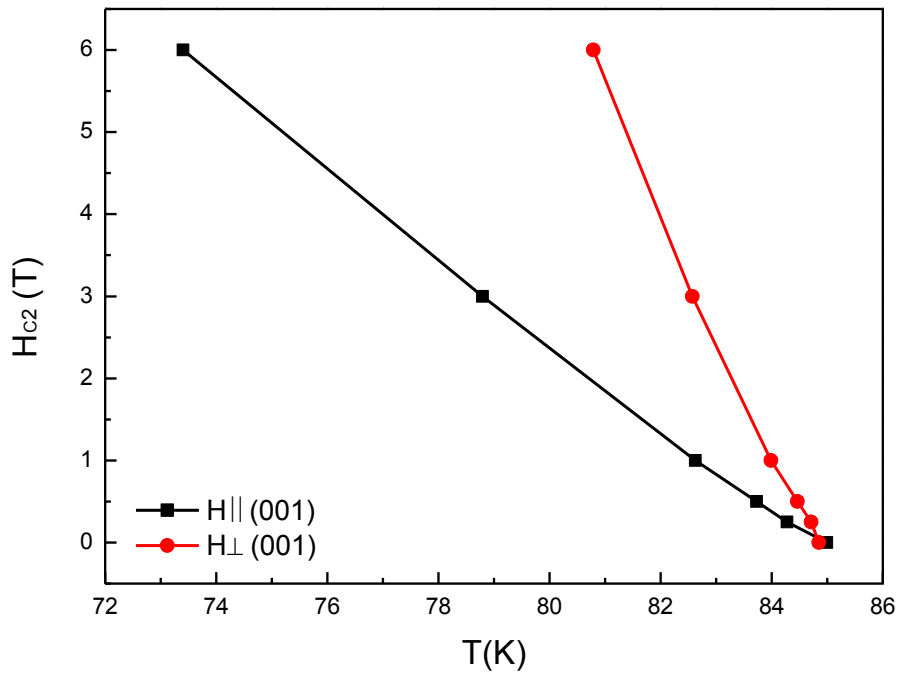


Figure 4.1.8: Temperature dependence of the upper critical field $H_{c2}(T)$ for both field directions.

According to Anderson and Kim's flux creep model [5, 6]:

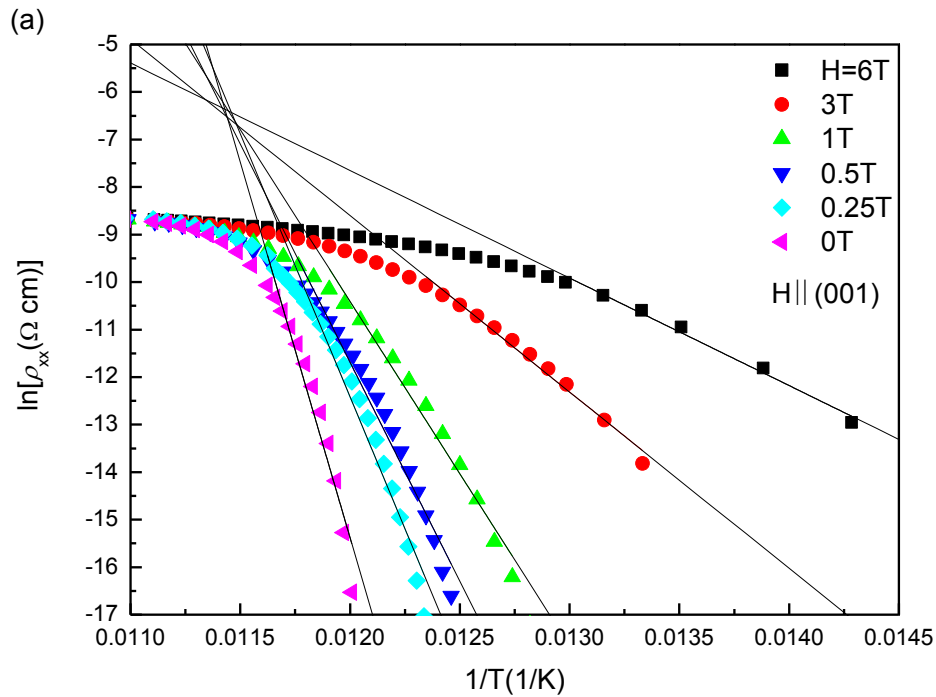
$$\rho(T, H) = \rho_0 \exp\left(-\frac{U_0}{k_B T}\right)$$

so the relation of $\ln\rho - 1/T$ can be described as

$$\ln\rho(T, H) = \ln\rho_0(H) - U_0/k_B T$$

where $\ln\rho_0(H) = \ln\rho_{0f} + \frac{U_0}{k_B T_c}$ is the temperature independent constant and U_0 is the apparent activated.

$U(T, H)$ tends to zero just above the onset of T_c because the superconductivity will vanish when temperature is above the onset of T_c . Then U_0 can be obtained from the slope of the linear part of the $\ln\rho - 1/T$ plot as shown in figure 4.1.8.



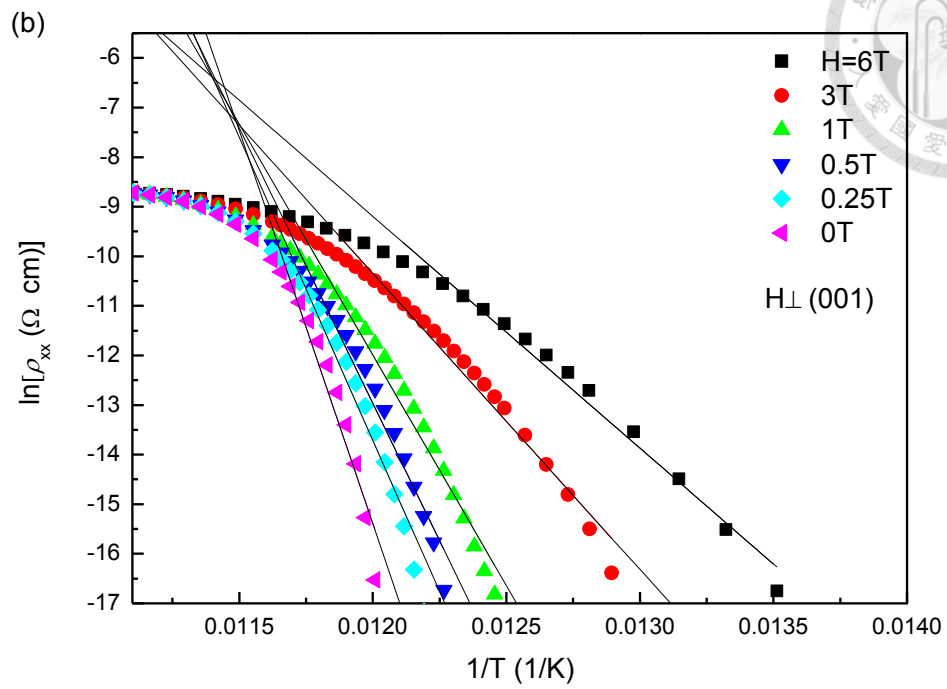


Figure 4.1.9: $\ln\rho(T,H)$ vs $1/T$ in various fields for (a) $H \parallel (001)$ and (b) $H \perp (001)$.

The U_0 - H relation shown in figure 4.1.9 can be obtained from figure 4.1.8. We can see that the apparent activated U_0 (K) decreases with the increase of applied magnetic field both in $H \parallel (001)$ and $H \perp (001)$. The temperature scale for the activation energy can be normalized as U_0/T .

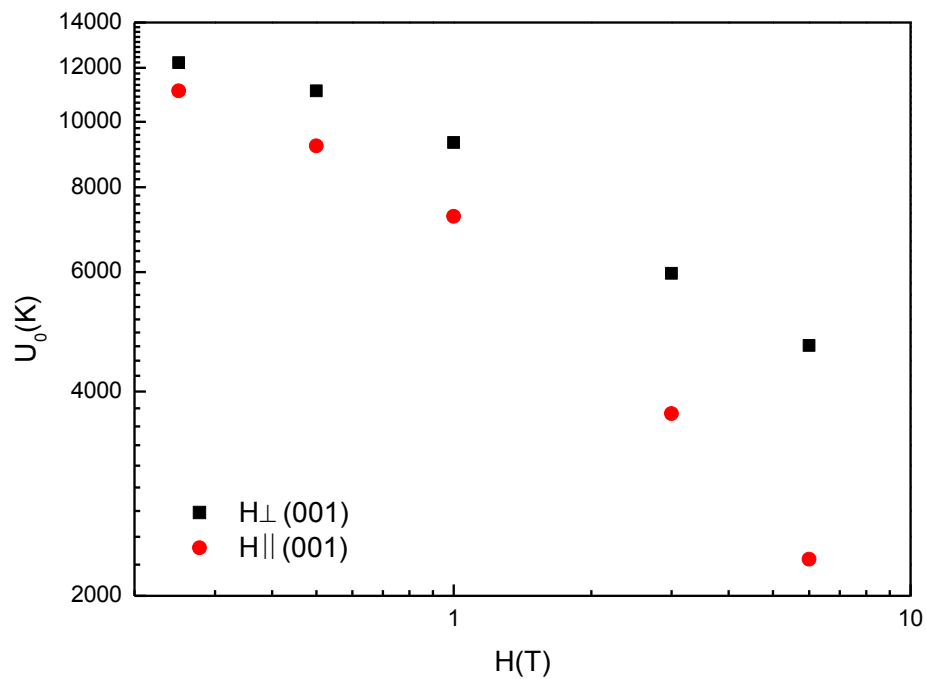


Figure 4.1.10: Field dependence of U_0 (K).

4.2 The SNS structure



According to the previous statements in chapter 3, we fabricated the SNS structure with the technique of Focused Ion Beam (FIB). Then we also checked the two electrodes whether those were disconnected before we coated the gold on the part of cutting regions. Then we annealed the SNS structure because of the importance of annealing. The optical image of the sample is shown in figure 4.2.1.

The experiment was carried out in a cryostat system. The SNS structure was measured by Keithley 236 and Keithley 2000 multi-meter with four-terminal techniques. The R-T data of the SNS structure was recorded automatically by a computer equipped with a Labview program.

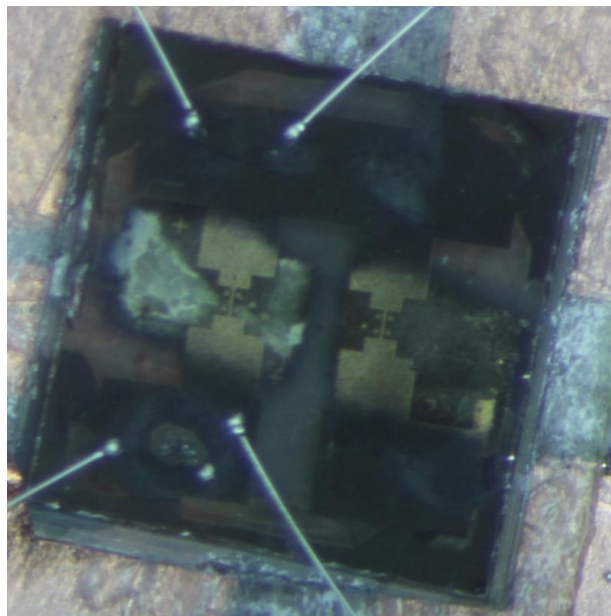


Figure 4.2.1: The optical image of the SNS structure. (This device was made by Lung-Yi Huang and Yu-Feng Huang.)

If the SNS structure is in the superconducting state, then the resistance of the structure will drop to zero, which means that we can observe it from the $R-T$ curve. At the beginning, the current was applied with $I = 10\mu\text{A}$. The $I-V$ curve is shown in figure 4.2.2. The time range of annealing was about one hour, and it was input near 1Atm-oxygen for annealing [7].

As shown in Fig. 4.2.2, the resistance of the SNS structure jumped to a very small value when the temperature was about 40K. The contact resistance remained unchanged with the temperature. The result was consistent with the earlier report [8]. The contact resistance can be reduced by annealing with better condition, and then the supercurrent can be observed.

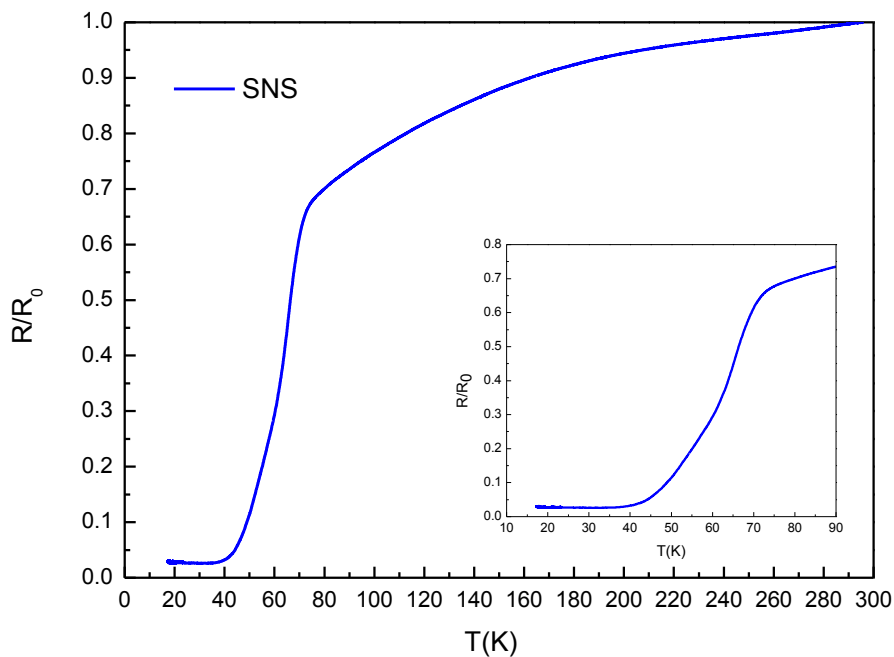


Figure 4.2.2: The $R-T$ curve of the SNS structure. (This diagram was made by Lung-Yi Huang and Yu-Feng Huang.)

4.3 The SGS structure

We fabricated new superconducting electrodes with the gap of about 100 nm by Focused Ion Beam (FIB). The graphene was transferred on the bridge between two superconducting electrodes shown in figure 4.3.1. Because the graphene is transparent and hard to be seen, therefore we measured the resistance of the SGS structure at room temperature for checking whether we make it successfully.

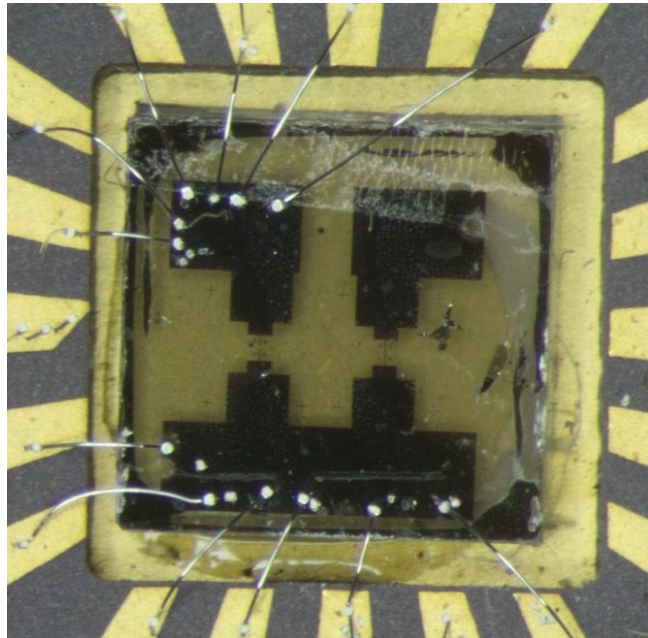


Figure 4.3.1: The optical image of the SGS structure. (This device was made by Lung-Yi Huang and Yu-Feng Huang.)

In order to identify the Ohmic region, we measure the I - V relation of the SGS structure before we cool down the device. The current-voltage (I - V) curve shown in figure 4.3.2 is linear at room temperature.

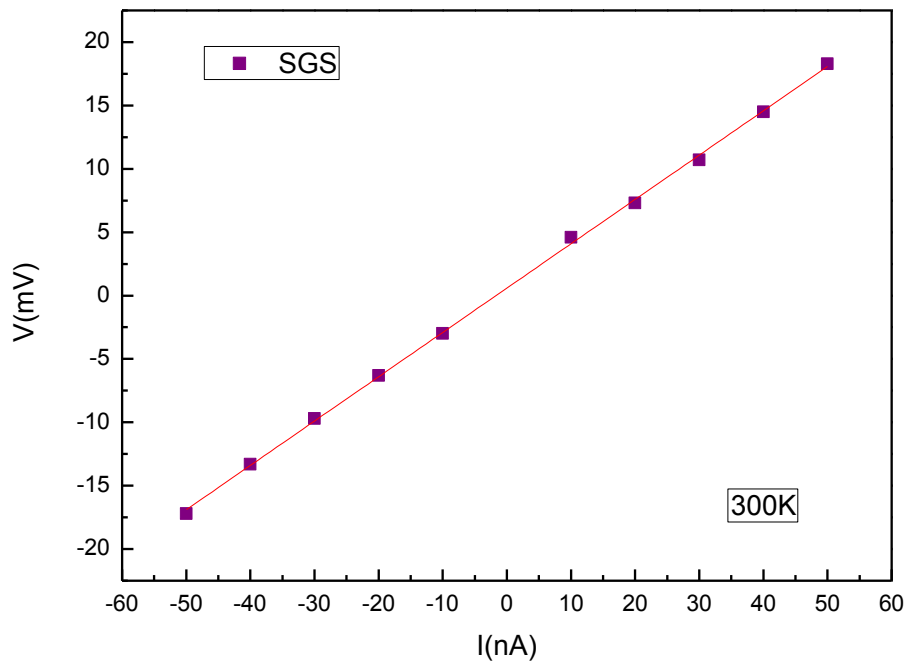
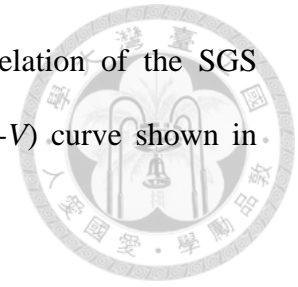


Figure 4.3.2: The current-voltage (I - V) curve of the SGS structure at 300K. (This diagram was made by Lung-Yi Huang and Yu-Feng Huang.)

The SGS structure was measured by Keithley 236 and Keithley 2000 multi-meter with four-terminal technique. The I - V curve shown in the figure 4.3.3 was about 10K. We found that the I - V curve at 10K is not linear from -90nA to 90nA. The slope changed from -50nA and 50nA. Although the intermediate part of the I - V curve is not very flat, the variation of resistance is clear. There is one reason led this happen. That is, there were only few amounts of cooper pairs passing through the graphene which connects two superconducting electrodes. On the other hand, the contact resistance is a big problem for this kind of structure. The contact resistance is too large to see the supercurrent, so the typical I - V curve of Josephson junction is not represented.

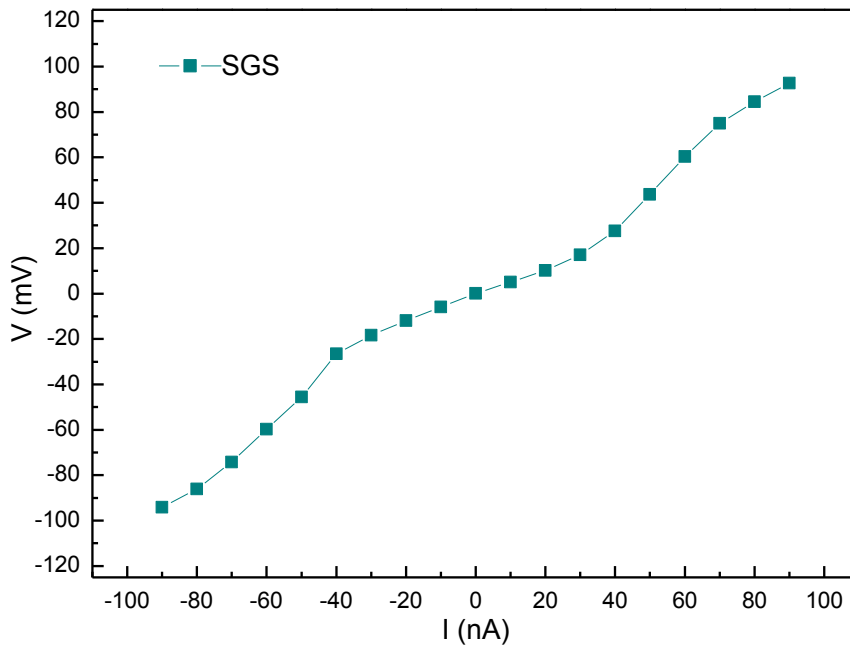


Figure 4.3.3: The current-voltage (I - V) curve of the SGS structure about 10K. (This diagram was made by Lung-Yi Huang and Yu-Feng Huang.)

The large contact resistance obstructs the characteristic that we want to observe. In order to check whether the reason is only from the large contact resistance, we measured the R - T of superconducting electrodes. It is shown in figure 4.3.4. The characteristic of superconductor still exists.

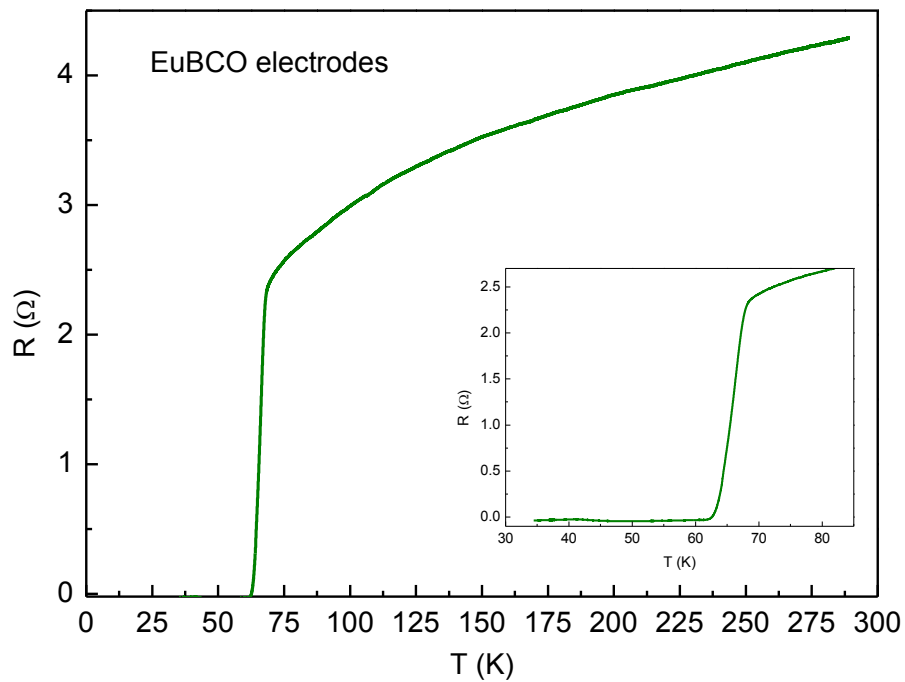


Figure 4.3.4: The R - T curve of the superconducting electrodes. (This diagram was made by Lung-Yi Huang and Yu-Feng Huang.)

References



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Chapter 5 Perspective



There are still problems we need to solve: The large contact resistance of the SGS structure and the quality of the EuBCO films.

The T_c of our EuBCO film is about 90K that is close to the result of paper [1]. Although the higher T_c is the indicator of the sample quality, but we didn't reduce the roughness successfully, the surface of our EuBCO film shown in figure 5.1 is still very rough. One can expect that a flatter surface of EuBCO would be helpful to our measurement. Nevertheless, we can not only attribute the large contact resistance of the SGS structure to the roughness of our EuBCO films.

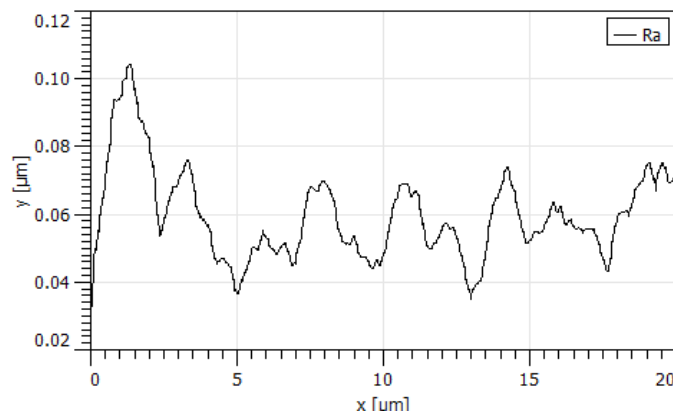
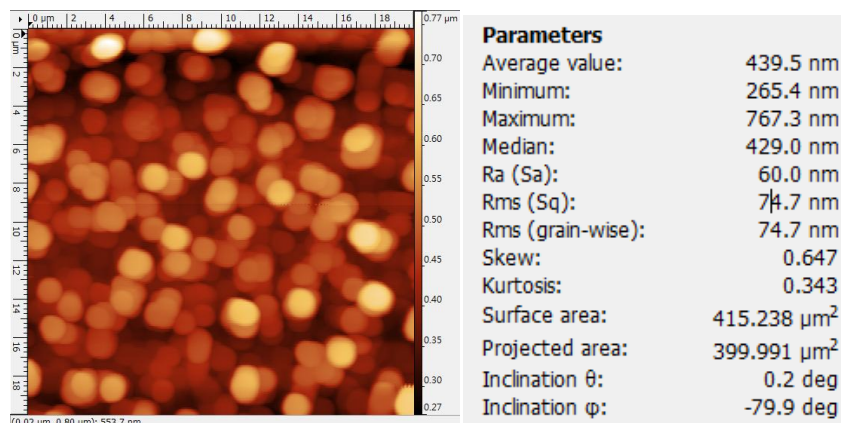


Figure 5.1: The roughness of surface for the EuBCO film.

Second, we can find the better condition of annealing the SGS structure, so that it can improve the interface between graphene and superconducting electrodes, just like the SNS structure we fabricated.

Third, we can put the gate on the SGS structure in the future, and then we can tune the gate voltage to enlarge the carrier density. We may see the supercurrent passing through the device because of the increment of carrier density [2].

Due to the different physical properties of graphene and superconductor, the interfaces should be improved. The improvement of interface between the graphene/superconductor is a challenge. If the problem is solved, the new physics may emerge.

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